



I/w  
PATENT  
AF#  
2881

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Tom Tse et al.

Title: METHOD AND SYSTEM FOR DOSE CONTROL DURING AN ION IMPLANTATION PROCESS

App. No.: 10/082,567 Filed: 02/25/2002

Examiner: Mary A. El Shammaa Group Art Unit: 2881

Customer No.: 34456 Confirmation No.: 3170

Atty. Dkt. No.: 1458-TT4763

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Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

**RESPONSE AFTER FINAL**

Dear Sir:

In response to the Final Action mailed November 20, 2003, and to the Advisory Action mailed March 15, 2004, please amend the above-identified application as follows:

CERTIFICATE OF TRANSMISSION/MAILING	
I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to the Commissioner for Patents on <u>4-20-04</u> .	
<u>KATRINA PRATI</u>	<u>KATRINA PRATI</u>
Typed or Printed Name	Signature